DESIGNATION OF INVENTORS

FIRST INVENTOR:

NAME:

GÜNTER SCHWAB

RESIDENCE:

EMMERTING, GERMANY

CITIZENSHIP: GERMAN

P.O. ADDRESS: LINDENWEG 2A

D-84547 EMMERTING, GERMANY

SECOND INVENTOR:

NAME:

HELMUT FRANKE

RESIDENCE: BURGHAUSEN, GERMANY

CITIZENSHIP: GERMAN

P.O. ADDRESS: LION-FEUCHTWANGER-WEG 8

D-84489 BURGHAUSEN, GERMANY

THIRD INVENTOR:

NAME:

MANFRED SCHÖFBERGER

RESIDENCE: REUT, GERMANY

CITIZENSHIP: GERMAN

P.O. ADDRESS: SIMBACHER STRASSE 9

D-84367 REUT, GERMANY

Title:

PROCESS FOR PRODUCING A SEMICONDUCTOR WAFER

Priority: GERMAN PATENT APPLICATION #100 02 354.1

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